## **AMENDMENTS**

## AMENDMENTS TO THE CLAIMS

1. (Currently amended) A method for sampling a high temperature process stream, wherein a temperature of the high temperature process stream is above a boiling point of a target sample component at a process stream pressure, the method comprising the steps of:

evacuating a low temperature zone of a sampling system using a <u>first</u> vacuum pump;

admitting a portion of the high temperature process stream into the low temperature zone through an orifice;

maintaining a stable vacuum pressure in the low temperature zone; introducing a sample from the low temperature zone of the sampling system into test equipment through a sample introduction valve, the test equipment comprising a mass spectrometer:

evacuating with a second vacuum pump a chamber of the mass spectrometer to a pressure lower than the stable vacuum pressure in the low temperature zone; and maintaining a temperature of the low temperature zone above a boiling point of the target sample component at the stable vacuum pressure.

- 2. (Original) The method of claim 1, wherein the orifice has a diameter of between 0.005 inches and 0.025 inches.
- 3. (Currently amended) The method of claim 1, wherein the step of maintaining a stable vacuum pressure in the low temperature zone includes metering flow to the <u>first</u> vacuum pump.
- 4. (Currently amended) The method of claim 1, wherein the step of maintaining a stable vacuum pressure in the low temperature zone includes controlling the <u>first</u> vacuum pump.
- 5. -6. (Canceled)
- 7. (Original) The method of claim 1, wherein the test equipment includes a mass

spectrometer.

- 8. (Original) The method of claim 1, wherein the test equipment includes a FT-ICR mass spectrometer.
- 9. (Currently amended) The method of claim 8, wherein the FT-ICR mass spectrometer includes a-the second vacuum pump, and the method further comprises the step of evacuating with the second vacuum pump a chamber of the FT-ICR to a pressure lower than the stable vacuum pressure in the low temperature zone.
- 10. (Original) The method of claim 1, wherein the stable vacuum pressure is between a pressure of the process stream and a high vacuum pressure of a vacuum chamber of the test equipment.

11. - 22. (Canceled)